
*** TX REPORT ***

TRANSMISSION OK

TX/RX NO	0255
RECIPIENT ADDRESS	6797#3994994#149832#15712731436#
DESTINATION ID	
ST. TIME	06/23 11:49
TIME USE	00'39
PAGES SENT	3
RESULT	OK

Facsimile Cover Sheet

SENDER'S FACSIMILE RECEIVING #: 614-227-2100

IF YOU HAVE RECEIVED THIS COMMUNICATION IN ERROR OR IF YOU HAVE ANY PROBLEMS RECEIVING THIS COMMUNICATION, PLEASE CALL (513) 948-1500 IMMEDIATELY. THANK YOU.

THE INFORMATION CONTAINED IN THIS COMMUNICATION IS CONFIDENTIAL AND SUBJECT TO ATTORNEY CLIENT, WORK PRODUCT, OR OTHER LEGAL PRIVILEGE. THIS COMMUNICATION IS INTENDED ONLY FOR THE USE OF THE INDIVIDUAL OR ENTITY NAMED AS RECIPIENT. IF THE READER OF THIS COMMUNICATION IS NOT THE INTENDED RECIPIENT, YOU ARE HEREBY NOTIFIED THAT ANY DISSEMINATION, DISTRIBUTION OR COPYING OF THIS COMMUNICATION IS STRICTLY PROHIBITED.

Date: June 23, 2010 User: 6797 Client Matter #: 3994994 - 149832

TOTAL NUMBER OF PAGES INCLUDING COVER SHEET: 3

PLEASE DELIVER TO:

NAME	FIRM	FACSIMILE #:	CONFIRMATION #.
1. RAM KACKAR	USPTO	571-273-1436	

Comments:

From: Melanie R. Martin-Jones Phone No. 614-227-2116
THE ORIGINAL OF THIS DOCUMENT WILL BE SENT BY:

- ☐ ORDINARY MAIL
 ☐ OVERNIGHT DELIVERY SERVICE
☐ MESSENGER
 ☒ THIS WILL BE THE ONLY FORM OF DELIVERY

In re:

Serial Number: 10/800,553

Filed: March 15, 2004

Attorney's Docket No.: 3994994-149832

TITLE: HOLDER FOR SAMPLE MATERIALS USED IN HIGH THROUGHPUT...

INVENTOR: HE, Ting et al.

Please revise the specification as follows:

[0021] Figure 6 shows a cross section of the holder detailing an individual mechanism in the overall array for securing an individual electrode in the holder assembly showing the configuration of the elements: face plate 71 and fastening screws 72 attaching to block or middle plate 46M and retainer or rear plate 73 with fastening screws 74. The substrate 46... is shown maintained in the opening 103 of the column 102a in the middle plate 102... which is concentrically aligned with opening 101... in the face plate. The spring 77 and electrode retainer 76 exert a force upon the electrode to secure the electrode at the spot area 80 at which the surface of the electrode is exposed to the plasma beam during the coating process. Small mask 75 in the opening 101... is at the base of a chamfer or bevel 71C in the opening 101... in faceplate 71. Thus the upper section of the electrode substrate 46... is inset into the face plate 71. A small oversize tolerance in the column 102... in middle plate 46M facilitates the insertion of the electrode. Large mask 90 overlays the face plate opening 101...

REPLACEMENT SHEET
 TITLE: HOLDER FOR SAMPLE MATERIALS USED IN HIGH THROUGHPUT PHYSICAL VAPOR
 DEPOSITION MATERIAL STUDIES
 INVENTOR: HE, Ting *et al.*
 CONTACT: EDWIN BARANOWSKI (614-227-2188)

Figure 6

